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Dated: October 27, 2005 Signature:

(Gregory E. Stanton)

Docket No.: 29936/39463
(PATENT)

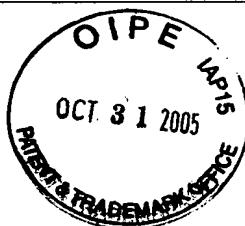
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Si B. Kim

Application No.: 10/616,722

Filed: July 10, 2003

For: **METHOD OF FORMING A COPPER WIRING
IN A SEMICONDUCTOR DEVICE**



Confirmation No.: 2678

Art Unit: 2812

Examiner: J. M. Kennedy

AMENDMENT

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This Amendment is submitted concurrently with a Request for Continued Examination in response to the Advisory Action dated October 13, 2005. Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.